JUL:	Application No. 10/735,216 Partindment Dated July 23, 2007 Reply to Final Office Action of June 1, 2007 2 7 2007 THE UNITED STATES PATI	PATENT ENT AND TRADEMARK OFFICE
5	In re the application of:)
	DORDI et al.) Examiner: Nguyen, Thanh T.
10	Application No.: 10/735,216) Art Unit: 2813)
10	Filed: December 12, 2003) Docket No.: LAM2P458) Date: July 23, 2007
	For: METHOD AND APPARATUS FOR MATERIAL DEPOSITION IN)) .
15	SEMICONDUCTOR FABRICATION	<u> </u>
20		CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 23, 2007.
25		Signed: Kenneth D. Wright

AMENDMENT

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

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This Amendment is submitted in reply to the Final Office Action dated June 1, 2007, and within the TWO MONTH period for reply extending to August 1, 2007. Please enter the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Amendment.

Remarks/Arguments begin on page 7 of this Amendment.